

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination LEE ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0178514	09-2004	Lee et al.	257/787
	B	US-			
	C	US-			
	D	US-			
	E	US-			
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	K	US-			
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**FOREIGN PATENT DOCUMENTS**

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